



Docket No.: 052775-0024

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Masahiro NAKAYAMA, et al. : Confirmation Number: 1716  
Application No.: 10/662,524 : Group Art Unit: 3723  
Filed: September 16, 2003 : Examiner: Dung V. Nguyen

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND  
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

**PETITION FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated March 15, 2006, now due to expire June 15, 2006, be extended for one (1) month and set to expire on July 15, 2006.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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**Date: July 17, 2006**

**Please recognize our Customer No. 20277  
as our correspondence address.**

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01 FC:1251 120.00 DA